

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Attorney Docket No.: 46884-5317	Serial No.: 10/507,321
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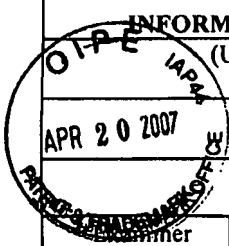
*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

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	Document Number	Date	Country	Class	Sub Class	Translation	
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/EU/	WO 2004/082006 A1	September 23, 2004	PCT	—	—	Abstract	

Examiner /Elias Ullah/ (06/19/2007)	Date Considered 06/19/2007
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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
/EU/	2004/0002199	January 1, 2004	Fukuyo et al.	-	-	
	2005/0189330	September 1, 2005	Fukuyo et al.	-	-	
	2006/0040473	February 23, 2006	Fukuyo et al.	-	-	
	3,626,141	December 7, 1971	Daly, Richard T.	-	-	
	3,790,051	February 5, 1974	Moore	-	-	
	4,531,060	July 23, 1985	Suwa et al.	-	-	
	5,230,184	July 27, 1993	Bukhman	-	-	
	5,841,543	November 24, 1998	Guldi et al.	-	-	
	5,925,271	July 20, 1999	Polluck et al.	-	-	
	5,968,382	October 19, 1999	Matsumoto	-	-	
	5,976,392	November 2, 1999	Chen	-	-	
	6,175,096	January 16, 2001	Nielsen	-	-	
	6,325,855	December 4, 2001	Sillmon et al.	-	-	
	6,992,026	January 31, 2006	Fukuyo et al.	-	-	
	2002/0170896	November 21, 2002	Choo et al.	-	-	
/EU/	3,610,871	October 5, 1971	Lumley, Robert M.	-	-	

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/EU/	03-234043	October 18, 1991	Japan	—	—	Abstract	
	04-029352	January 31, 1992	Japan	—	—	Abstract	
	04-356942	December 10, 1992	Japan	—	—	Abstract	
	08-197271	August 6, 1996	Japan	—	—	Abstract	
	10-071483	March 17, 1998	Japan	—	—	Abstract	
	10-214997	August 11, 1998	Japan	—	—	Abstract	
	10-233373	September 2, 1998	Japan	—	—	Abstract	
	2000-104040	April 11, 2000	Japan	—	—	Abstract	
	2000-195828	July 14, 2000	Japan	—	—	Abstract	
/EU/	2000-216114	August 4, 2000	Japan	—	—	Abstract	

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F. Fumitsugu, "The Stealth Dicing Technologies and Their Applications," Journal of Japan Laser Processing Society, Vol. 12, No. 1, February 2005, pp. 17-23, with English translation.

R. Sugiura et al., "The Stealth Dicing Technologies and Their Applications," Proceedings of the 63rd Laser Materials Processing Conference, May 2005, pp. 115-123, with English abstract.

A. Ishii et al., "CO2 Laser Processing Technology, Nikkan Kogyo Publishing Production, December 21, 1992, pps. 63-65 (with partial English translation)

Journal of the Japan Society of Grinding Engineers, Vol. 47, No. 5, May 2003, pps. 229-231, English translation.

K. Hayashi, "Inner Glass Marking by Harmonics of Solid-state Laser," Proceedings of 45th Laser Materials Processing Conference, December 1998, pps. 23-28, with English abstract.

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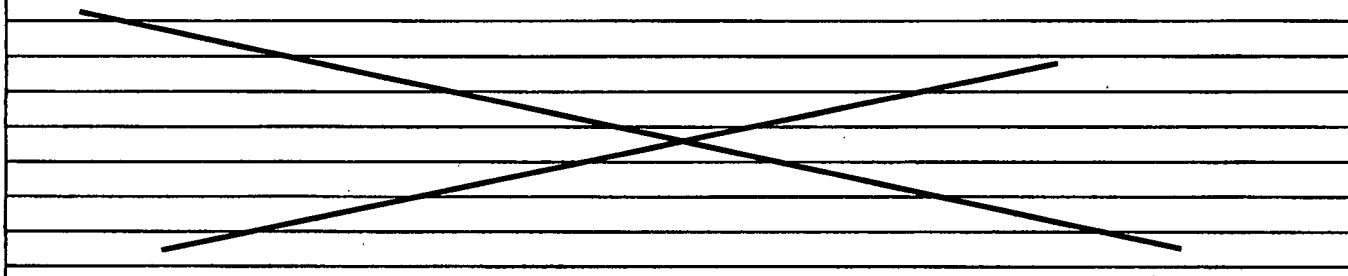
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/EU/	2000-219528	August 8, 2000	Japan			Abstract	
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	2001-250798	September 14, 2001	Japan			Abstract	
	2002-050589	February 15, 2002	Japan			Abstract	
	2002-192370	July 10, 2002	Japan			Abstract	
	2002-205181	July 23, 2002	Japan			Abstract	
	2002-226796	August 14, 2002	Japan			Abstract	
	2003-001458	January 8, 2003	Japan			Abstract	
	2005-047290	February 24, 2005	Japan			Abstract	
	2005-313237	November 10, 2005	Japan			Abstract	
	WO 01/90709 A1	November 29, 2001	PCT			Abstract	
	WO 02/22301	March 21, 1002	PCT			Abstract	
/EU/	KR2001-017690 (Abstract)	August 13, 1999	Korea			Abstract	

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K. Midorikawa, "Recent Progress of Femtosecond Lasers and Their Applications to Material Processing", December 31, 1998, pp. 29-38, ISBN: 4-947684-21-6, with English language abstract.

The 6th International Symposium on Laser Precision Microfabrication, April 2005, Symposium Program and Technical Digest, including F. Fukuyo et al., "Stealth Dicing Technologies and Their Applications," English abstract.



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/EU/	JP 2002-192368	July 10, 2002	JP	—	—	Abstract	

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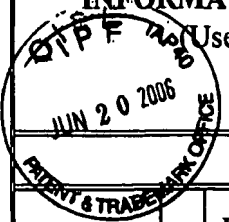
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/EU/	JP 8-264488	October 11, 1996	JP			Abstract	
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	JP 4-188847	July 7, 1992	JP			Abstract	
	JP 7-263382	October 13, 1995	JP			Abstract	
	JP 9-263734	July 10, 1977	JP			Abstract	
	JP 2002-158276	May 31, 2002	JP			Abstract	
	JP 2006-135355	May 25, 2006	JP			Abstract	
	JP 2006-128723	May 18, 2006	JP			Abstract	

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	Document Number	Date	Country	Class	Sub Class	Translation	
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/EU/	11-162889	June 18, 1999	Japan			X (abstract)	
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	2003-334812	Nov. 25, 2003	Japan			X (abstract)	
	2000-042764	Feb. 15, 2000	Japan			X (abstract)	
	05-335726	Dec. 17, 1993	Japan			X (abstract)	
	2003-338467	Nov. 28, 2003	Japan			X (abstract)	
	05-335726	Dec. 17, 1993	Japan			X (abstract)	
	2003-338467	Nov. 28, 2003	Japan			X (abstract)	
	11-163097	June 18, 1999	Japan			X (abstract)	
	06-188310	July 8, 1994	Japan			X (abstract)	
	WO 03/076118 A1	Sept. 18, 2003	PCT			X (abstract)	
	2002-192369	Oct. 7, 2002	Japan			X (abstract)	
	2005-159378	June 16, 2005	Japan			X (abstract)	
	2005-159379	June 16, 2005	Japan			X (abstract)	
	2002-192371	July 10, 2002	Japan			X (abstract)	
 							

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/EU/	5,656,186	August 12, 1997	Mourou et al.	-	-	
/EU/	5,543,365	August 6, 1996	Wills et al.	-	-	

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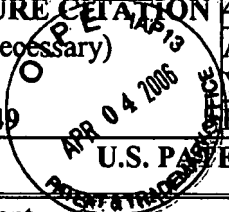
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/EU/	WO 02/07927 A1	January 31, 2002	PCT	—	—		
/EU/	60-055640	March 30, 1985	JP	—	—	Abstract	

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/EU/	5,211,805	May 18, 1993	Srinivasan	-	-	

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/EU/	10-305420	November 17, 1998	JP	—	—	Abstract	
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/EU/	07-037840	February 7, 1995	JP	—	—	Abstract	
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/EU/	2001-326194	November 22, 2001	JP	—	—	Abstract	
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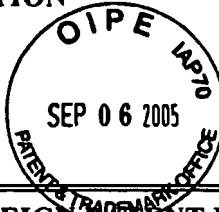
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/EU/	61-112345	May 30, 1986	Japan	—	—	Abstract	
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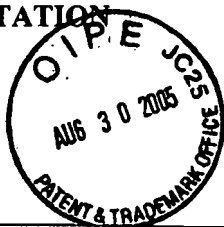
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Unassigned

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/EU/	4,562,333	Dec. 31, 1985	Taub et al.			
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	<i>Tooling Machine Series, Laser Machining</i> , published by Taiga Shuppan, Inc., Sept. 10, 1990, pps. 91-96
	<i>Electronic Material</i> , No. 9, on 2002, published by Kogyo Chousakai, pps. 17-21
	F. Fukuyo et al., "Stealth Dicing Technology for Ultra Thin Wafer", presented at 2003 ICEP (International Conference on Electronics Packaging), April 16-18, 2003, Tokyo, Japan

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	11-221684 A	Aug. 17, 1999	Japan			Abstract	
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	2000-219528 A	Aug. 8, 2000	Japan			Abstract	
	11-163403 A	Jun. 18, 1999	Japan			X	
	11-177137 A	July 2, 1999	Japan			X	
	64-38209	February 8, 1989	Japan			Abstract	6
	62-4341	January 10, 1987	Japan			Abstract	
	46-24989	July 19, 1971	Japan				X
	EP 863231	September 9, 1998	Europe				
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/EU/	K. Hayashi, "Inner Glass Marking by Harmonics of Solid-state Laser," Proceedings of 45th Laser Materials Processing Conference, Dec. 1998, pps. 23-28
	T. Sano et al., "Evaluation of Processing Characteristics of Silicon With Picosecond Pulse Laser," Preprints of the National Meeting of Japan Welding Society, No. 66, April 2000, pp. 72-73
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	T. Miyazaki, "Laser Beam Machining Technology," Published by Sangyo-Tosho Inc., May 31, 1991, First Edition. pps. 9-10

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